

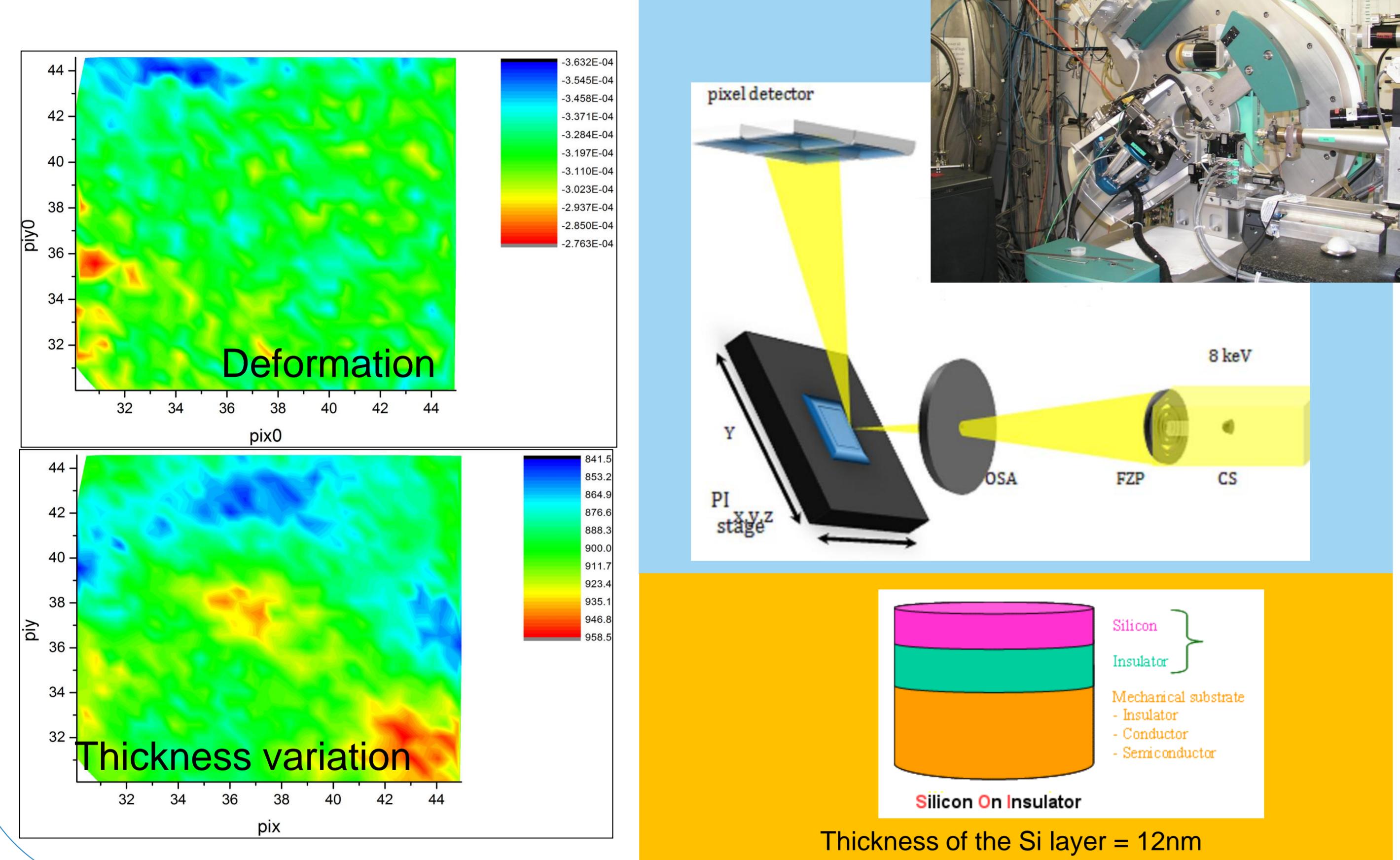
NON-CONVENTIONAL STRUCTURAL AND CHEMICAL CHARACTERISATIONS FOR THE INDUSTRY OF NANO-ELECTRONICS

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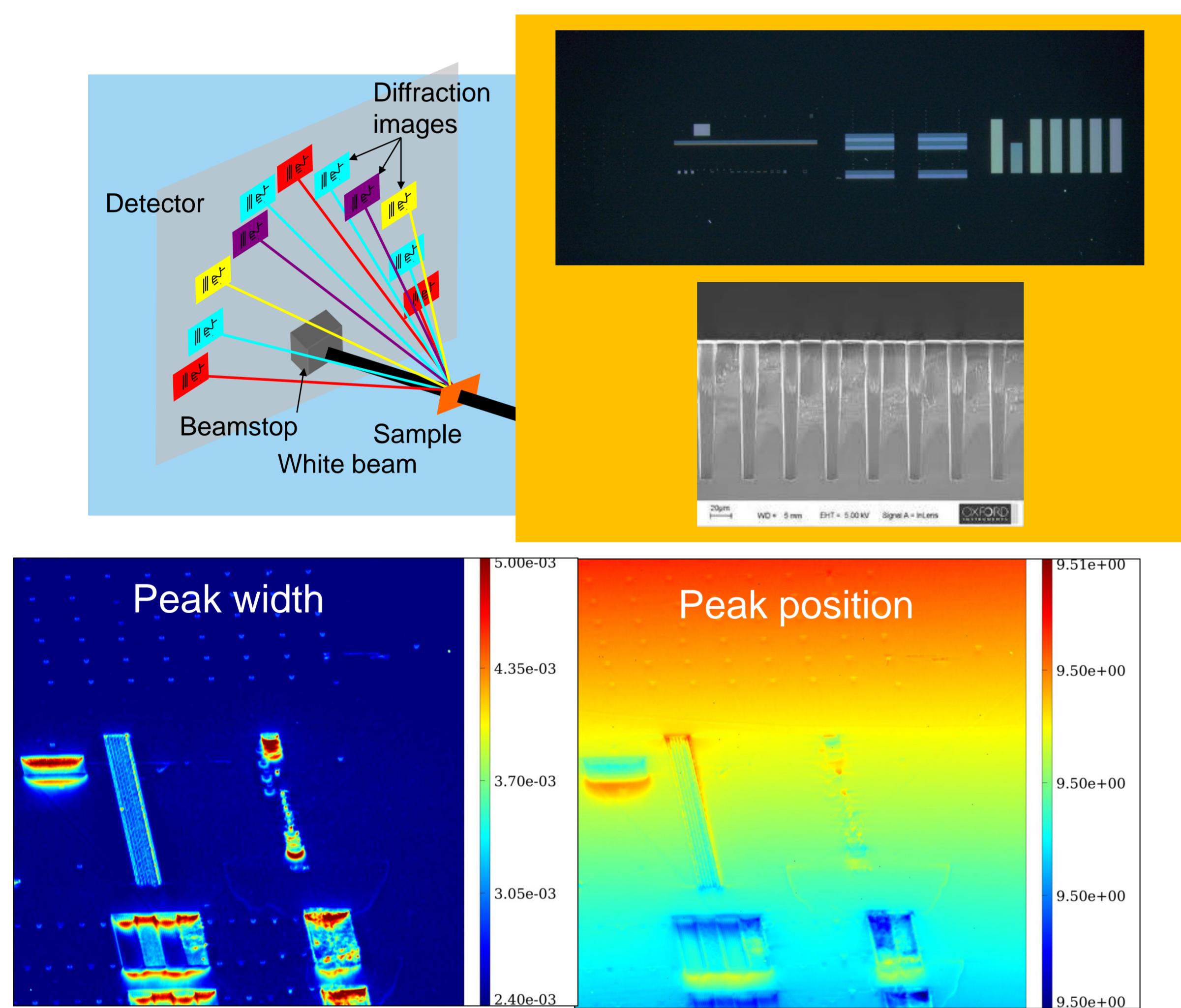
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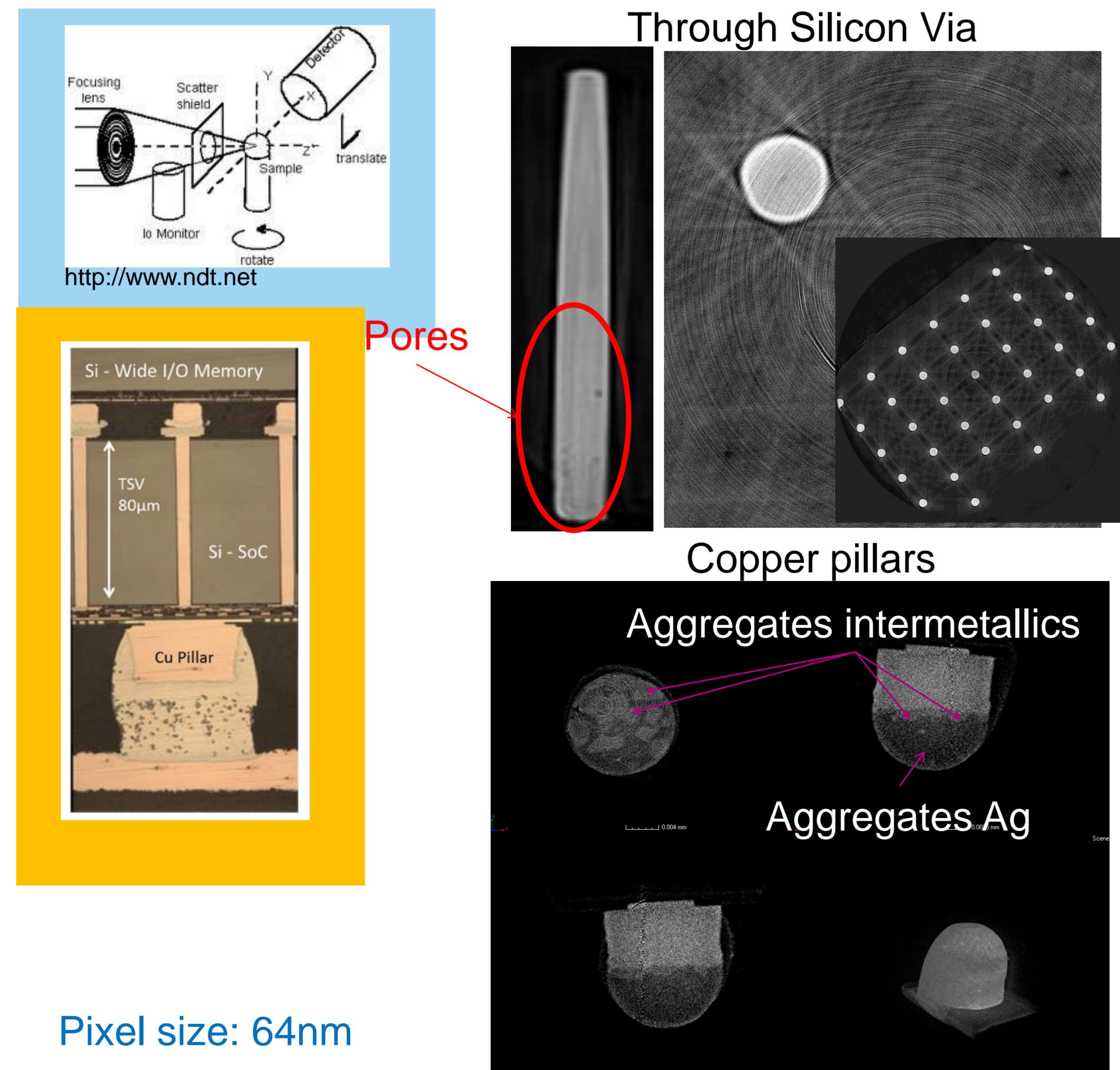
Residual strain and thickness of thin layers



Dislocations in single crystals



Defectology



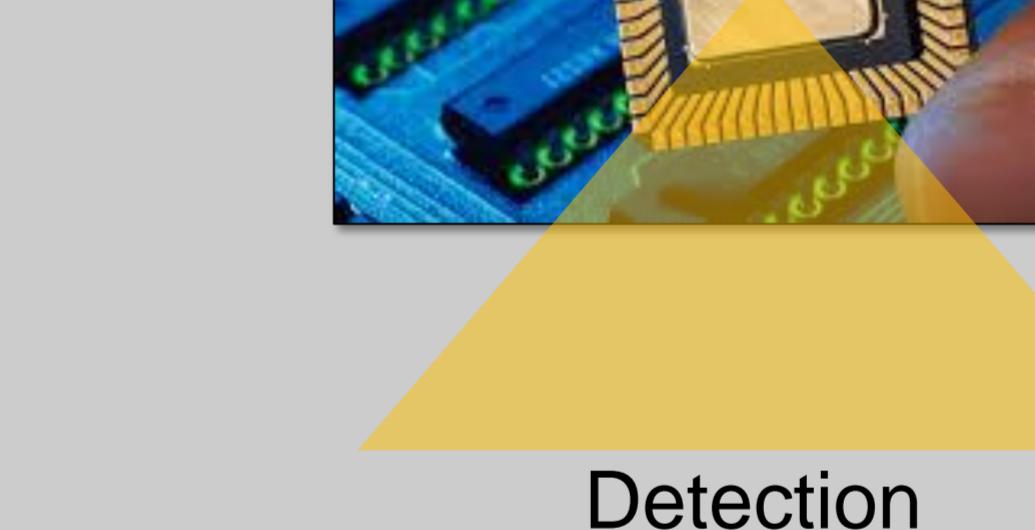
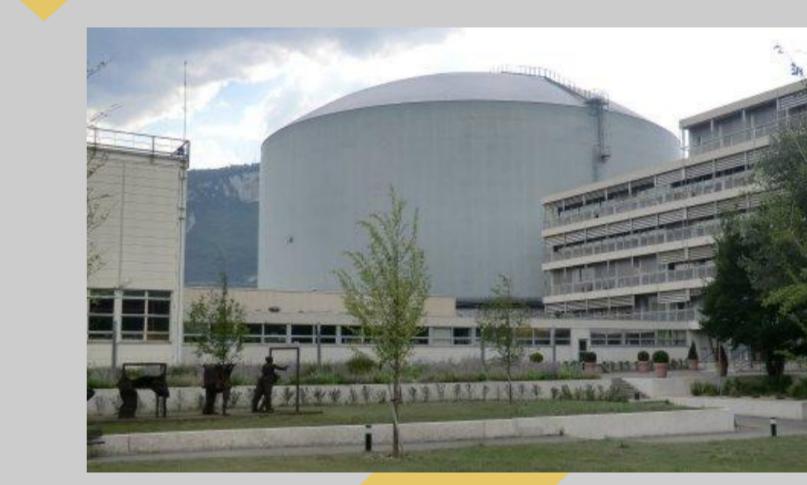
THE POWER OF LARGE SCALE RESEARCH INFRASTRUCTURES, SERVING INNOVATION

- THE MOST POWERFUL NEUTRONS SOURCE IN THE WORLD (ILL)
- ONE OF THE MOST BRILLIANT SYNCHROTRONS IN THE WORLD (ESRF)
- ULTIMATE NANO-CHARACTERISATION TOOLS FROM CEA (PFNC)

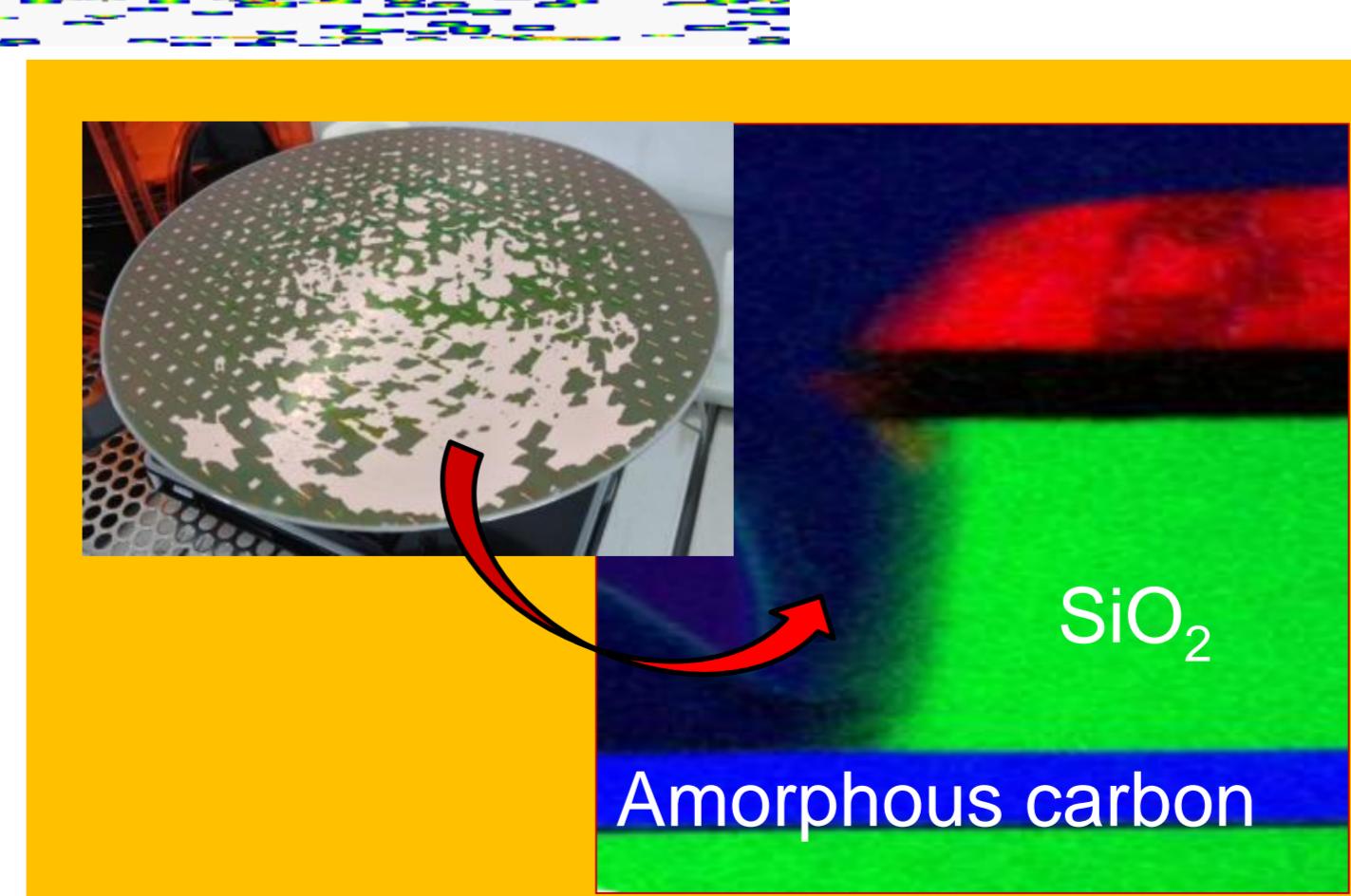
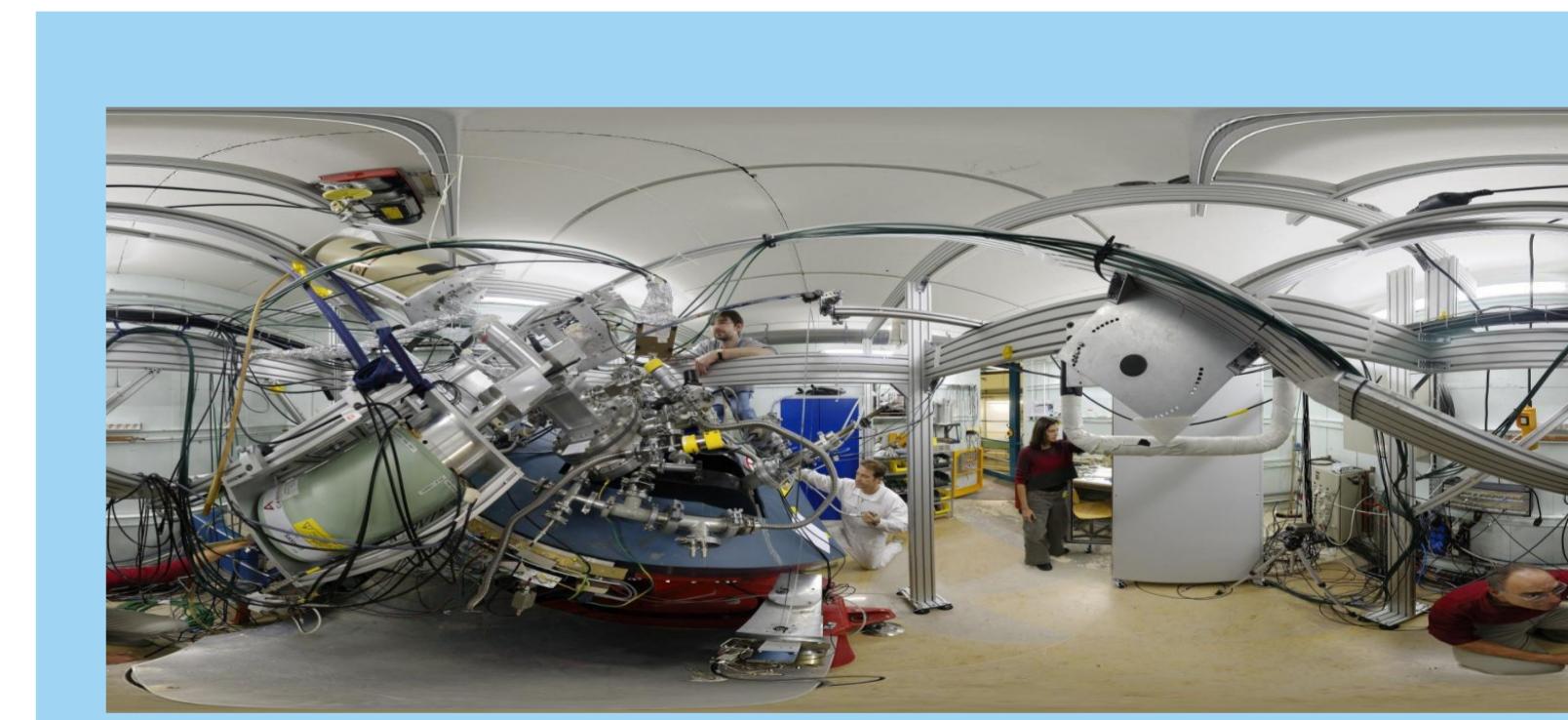
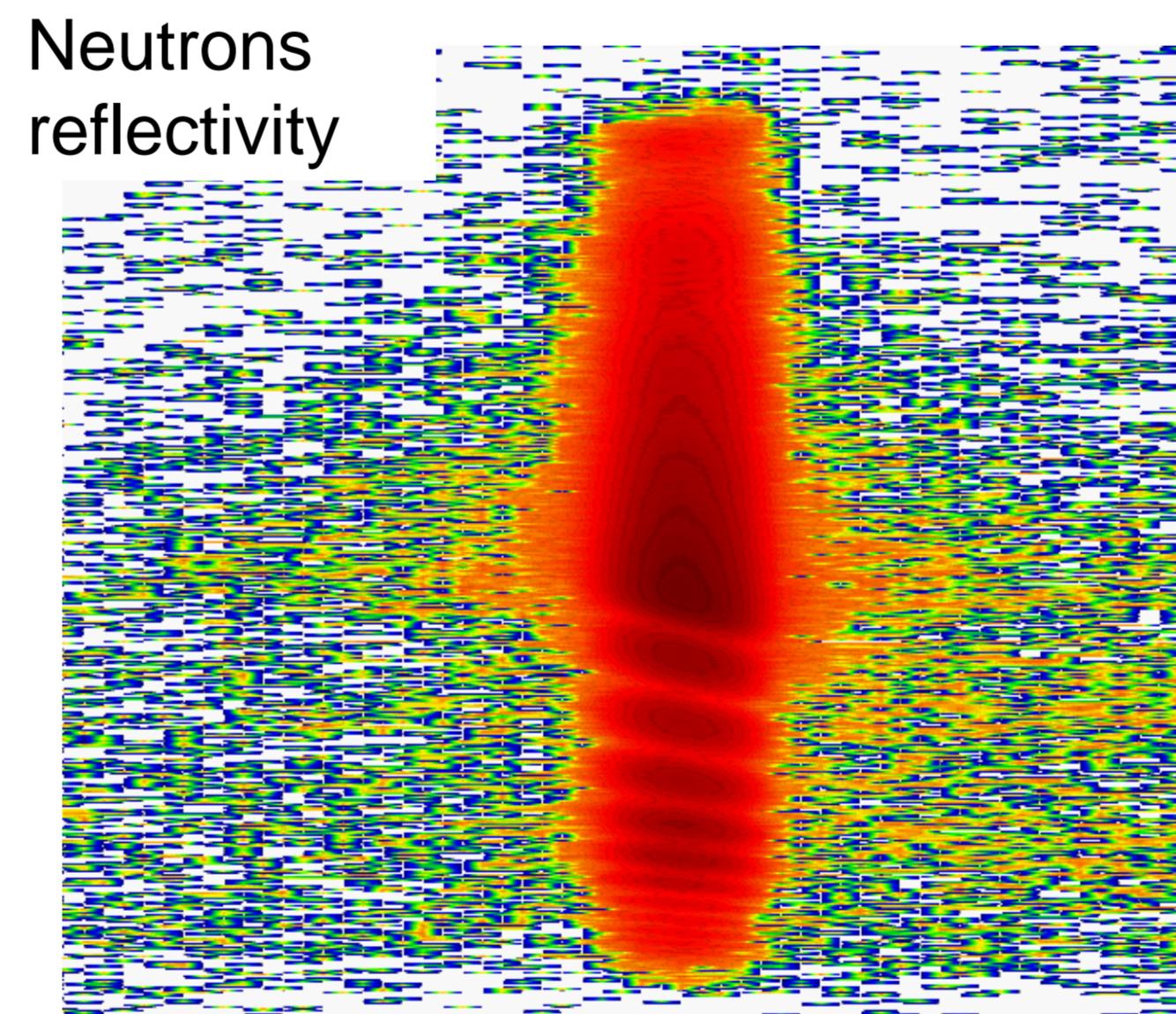
PFNC (CEA NanoCharacterisation platform)



Complementary characterisation Sample preparation



Characterisation of bonding interfaces



Ce travail a bénéficié d'une aide de l'Etat français au titre du programme d'investissements d'avenir, IRT Nanoelec, portant la référence ANR-10-AIRT-05.

